



AutoZero Technique

Supporting customer success in Automotive,
Medical and Industrial markets since 1991

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AutoZero Technique



- Used to compensate for temperature shifts over 5 to 10° C, stresses due to package mounting, and part-to-part variation.
- Take Zero Pressure reading, V_{O1} , at Temperature T_1
- Take new Pressure reading, V_{p1} and subtract V_{O1} , to obtain V_p reading. Use sensitivity from initial calibration to derive the Pressure Value.

AutoZero Process Guide



STEP 1: **Environmental Conditions:** Pressure = 0 PSI @ Temperature, T1

- Take pressure measurement, P01
- Store P01 as new offset value

STEP 2: **Environmental Conditions:** Pressure = A PSI @ Temperature, T1

- Take pressure measurement, PA1
- New Pressure Value, PA = PA1 – P01

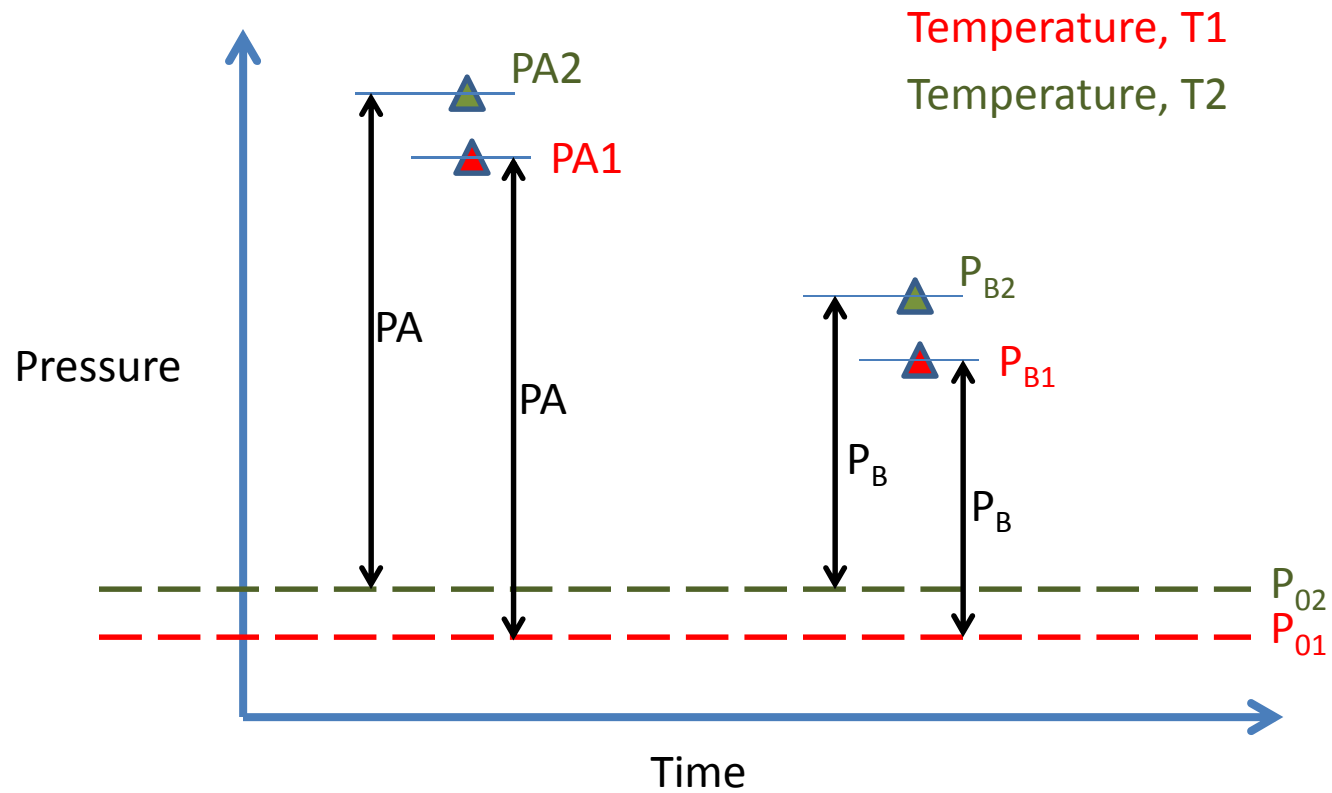
STEP 3: **Environmental Conditions:** Pressure = B PSI @ Temperature, T1

- Take pressure measurement, PB1
- New Pressure Value, PB = PB1 – P01

STEP 3: **Repeat Step 1 when possible as noted below:**

- If T1 increases or decreases more than 50C
- When Pressure at sensor equals 0 PSI
 - For example, when system is at power up or power down.

AutoZero Process Guide





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